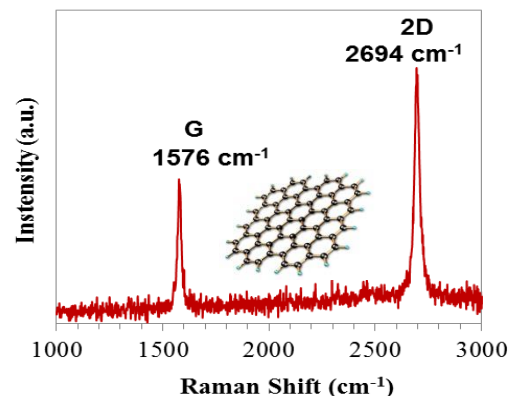
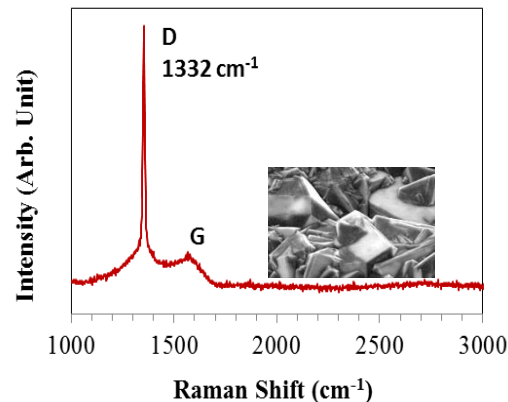




Micro Crystalline, Epilayer Diamond Nanodiamond CVD System

- ✚ Water cooled double wall stainless steel high vacuum chamber
- ✚ Easy filament holder assembly and flange
- ✚ DC low voltage power supply
- ✚ 2-4 Mass Flow Controllers of various ranges
- ✚ Mechanical and Optional Turbo vacuum pump
- ✚ Standard pressure gauges
- ✚ Optional stainless steel load lock chamber for high throughput
- ✚ Linear motion motorized control of Filament to substrate distance
- ✚ Versatile 2-8" diameter substrate heater with optional rotation.
- ✚ Optional Lab View computer Control